



Serial No. 10/023,948
SEC.861
Amendment dated August 7, 2003

1765
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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GROUP 1700

In re Patent application of :
Jae-dong Lee et al. : Group Art Unit 1765
Serial No. 10/023,948 : Examiner Lynette T. Umez-Eronini
Filed December 21, 2001 :
CHEMICAL MECHANICAL POLISHING SLURRY

AMENDMENT

U.S. Patent and Trademark Office
2011 South Clark Place
Customer Window, **Mail Stop Non-Fee Amendment**
Crystal Plaza Two, Lobby, Room 1B03
Arlington, VA 22202

Sir:

In response to the Office action of May 7, 2003, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.